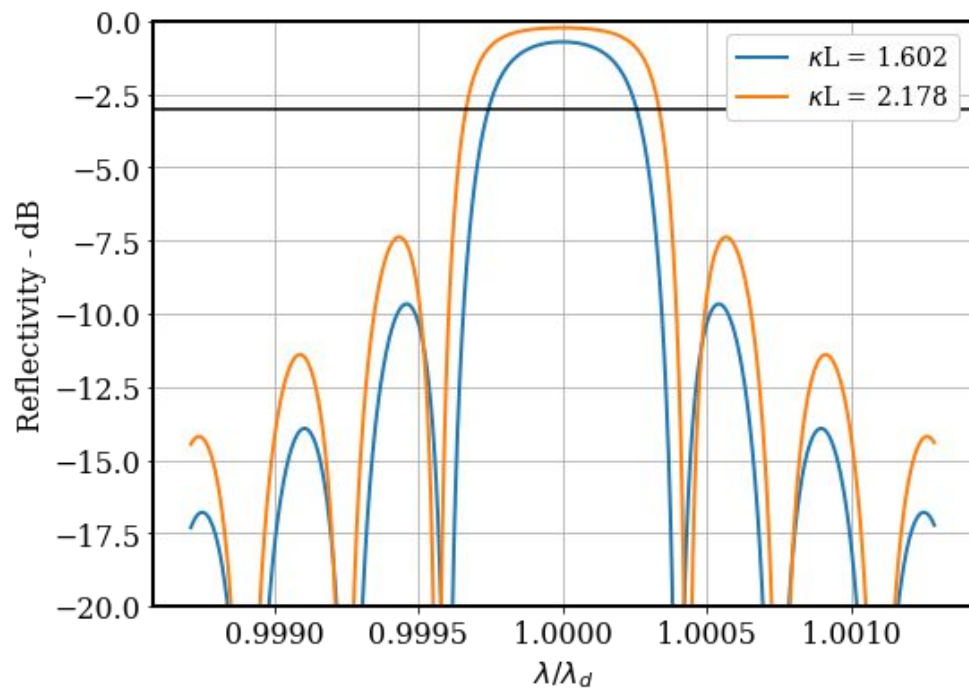
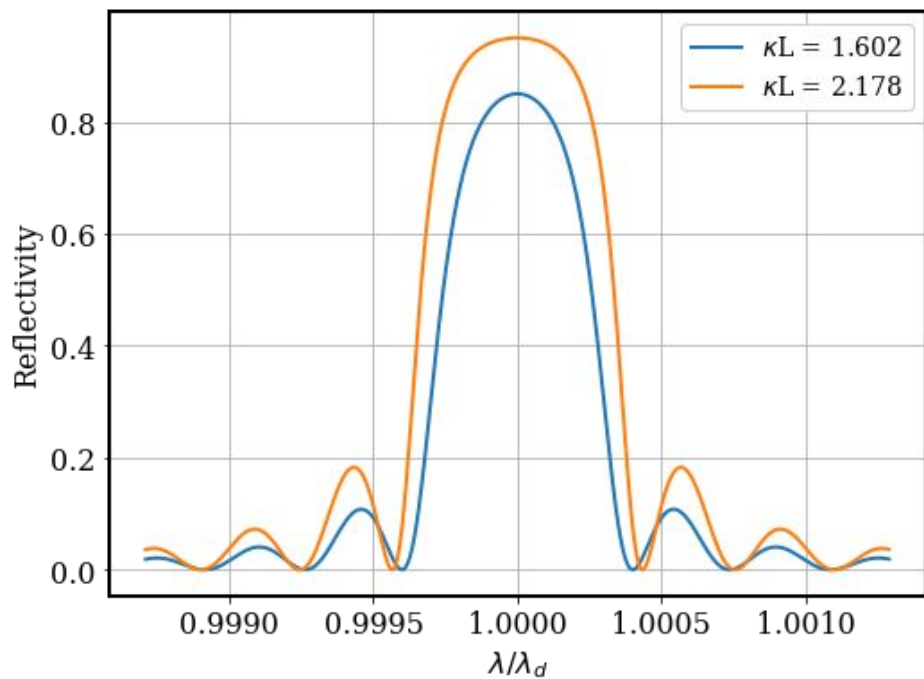


# BRAGG GRATING

Moisés de Araújo Oliveira



$L = 1.5 \text{ mm}$

$r_{\text{max\_1}} = 0.85$

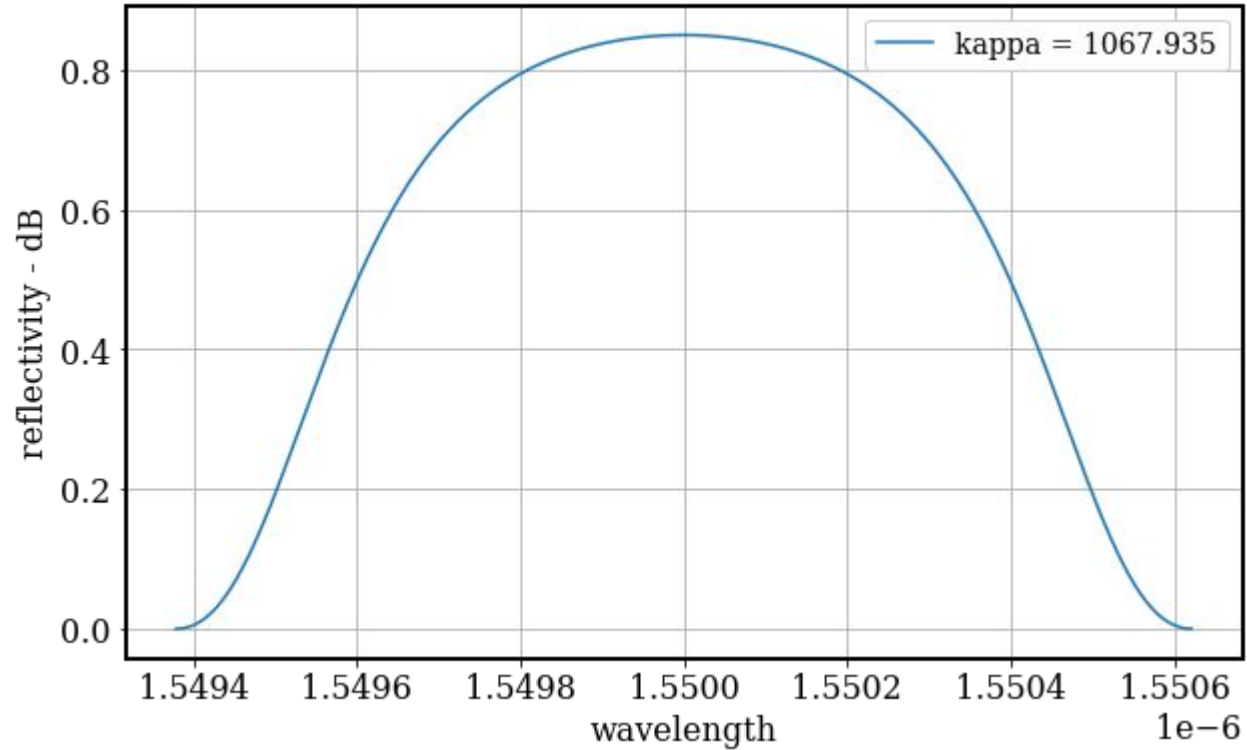
$r_{\text{max\_2}} = 0.95$

# Bandedge

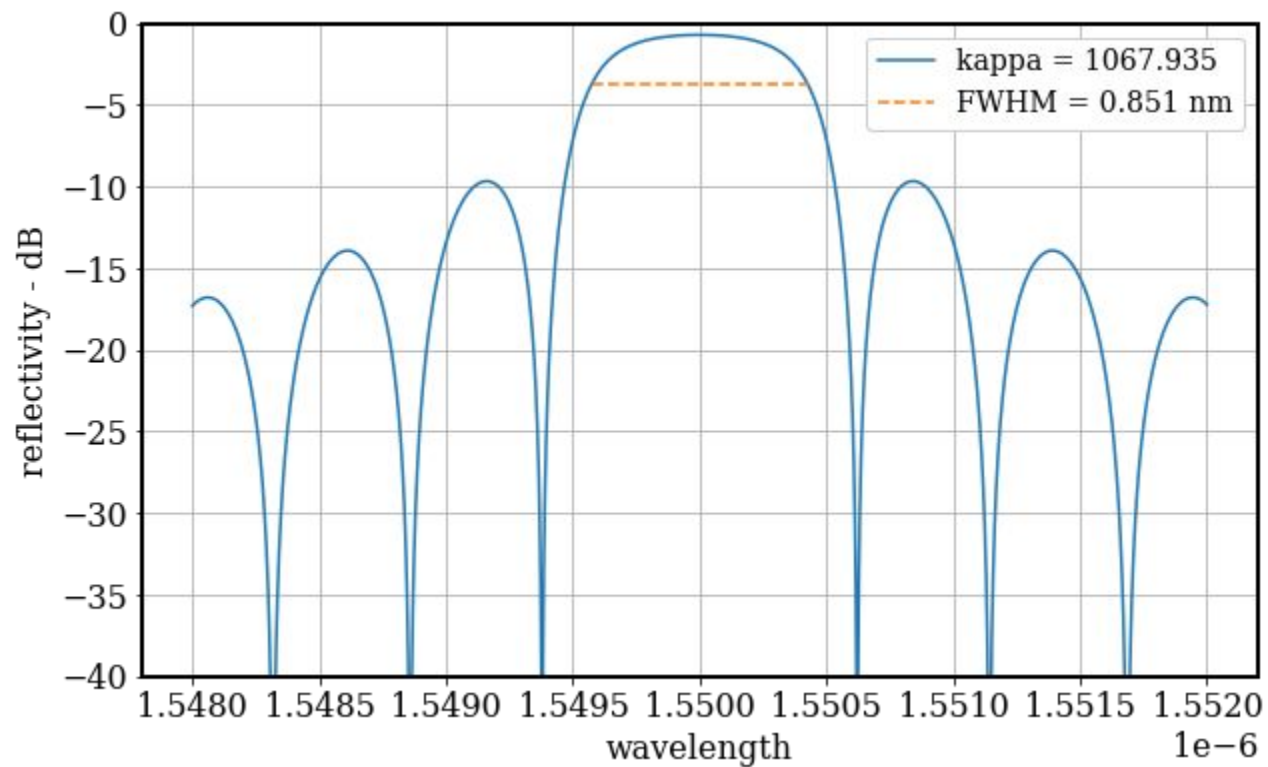
$$\lambda_{\text{bandedge}} = \lambda_{\text{max}} \pm \frac{v\overline{\delta n_{\text{eff}}}}{2n_{\text{eff}}} \lambda_D.$$

$$\frac{\Delta\lambda_{\text{bandedge}}}{\lambda} = \frac{v\overline{\delta n_{\text{eff}}}}{n_{\text{eff}}}$$

## Band between the first zeros



# FWHM



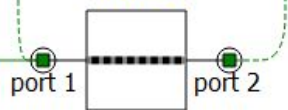
# Interconnect

ONA\_1



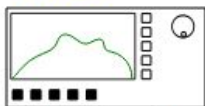
Properties:  
analysis type = scattering data

WBG\_1



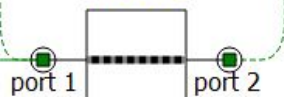
Properties:  
length = 0.0015 (m)

ONA\_2



Properties:  
analysis type = impulse response

WBG\_2



Properties:  
length = 0.0015 (m)

ONA\_3

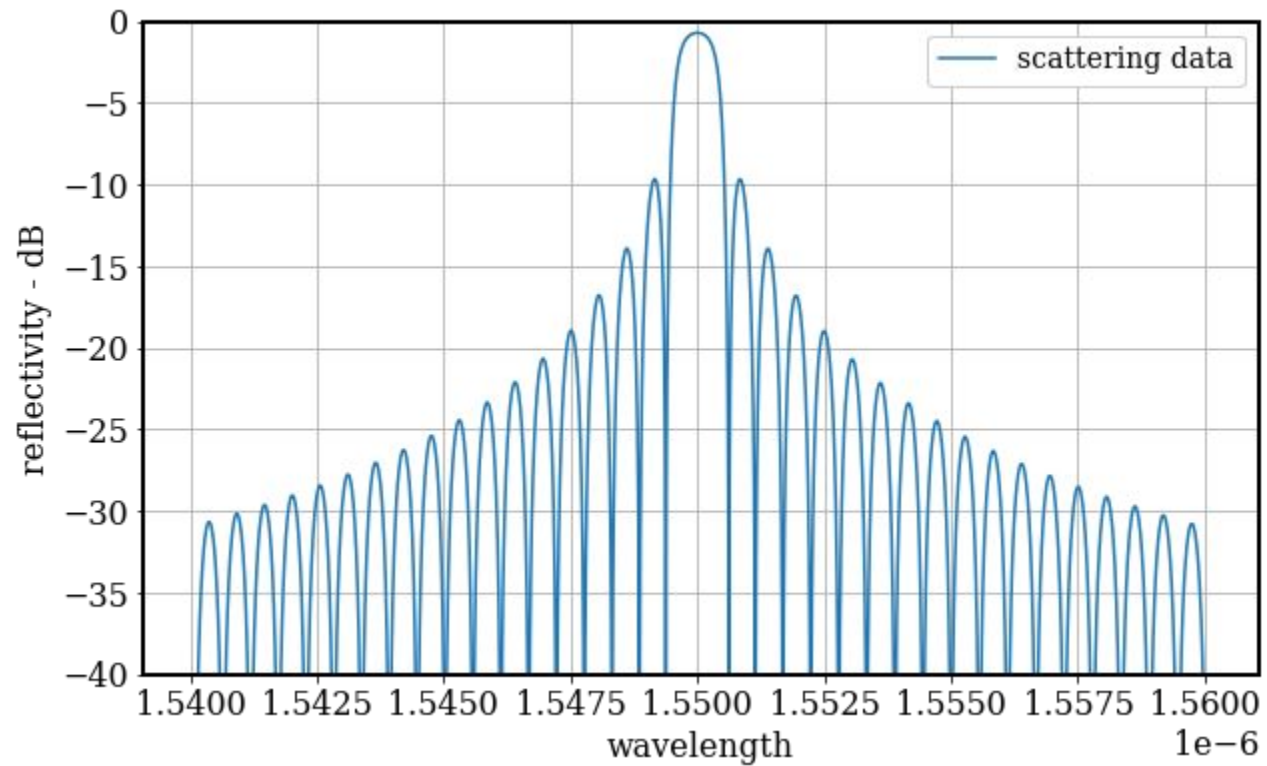


Properties:  
analysis type = impulse response

WBG\_3

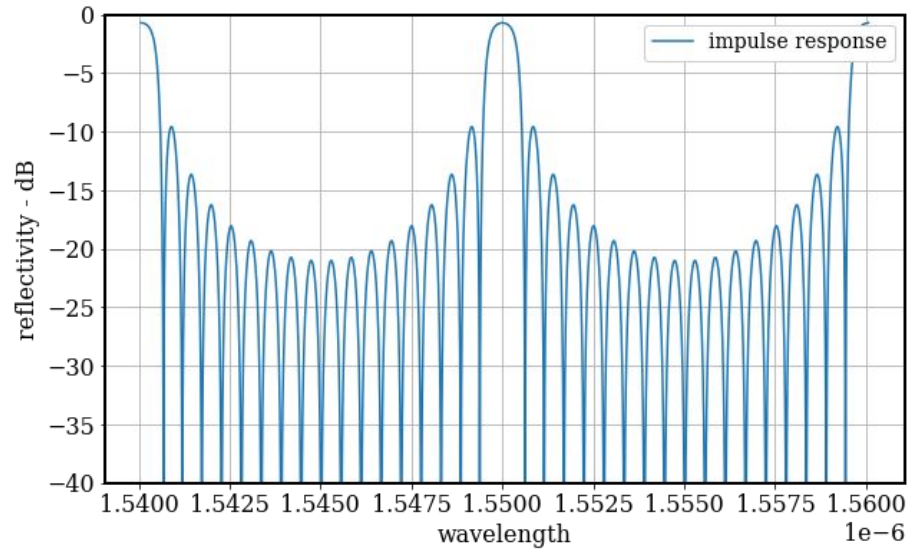


Properties:  
length = 0.0015 (m)



$L = 1.5 \text{ mm}$

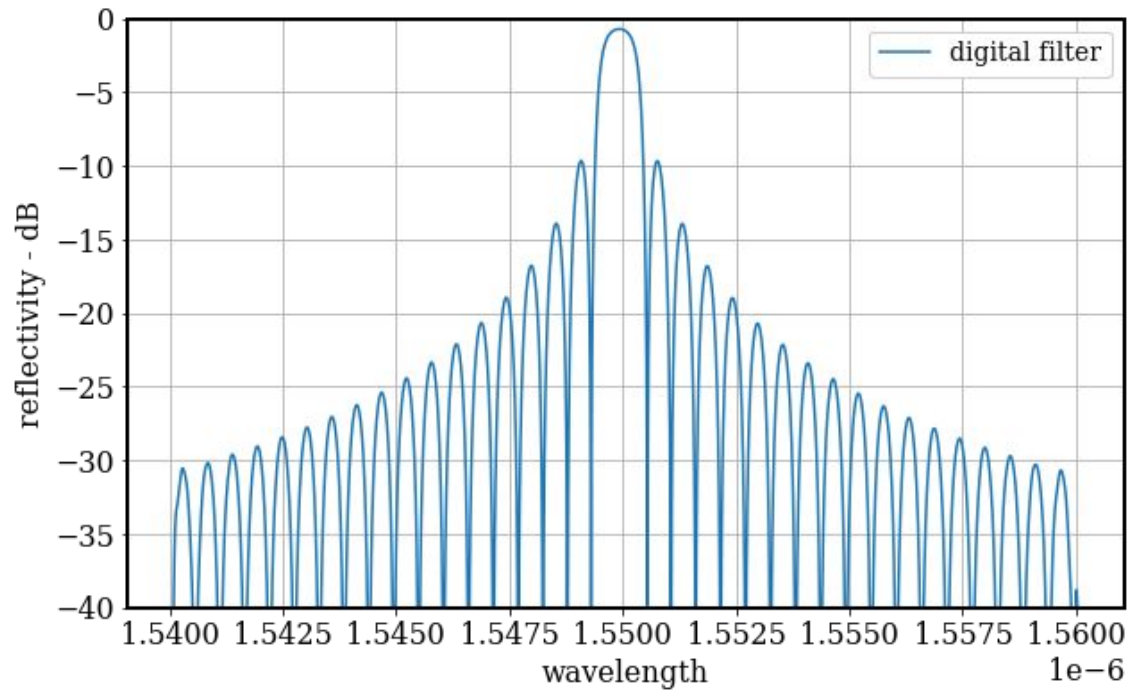
Effective index AC change = 0.000526898



Impulse response = True

digital filter = False

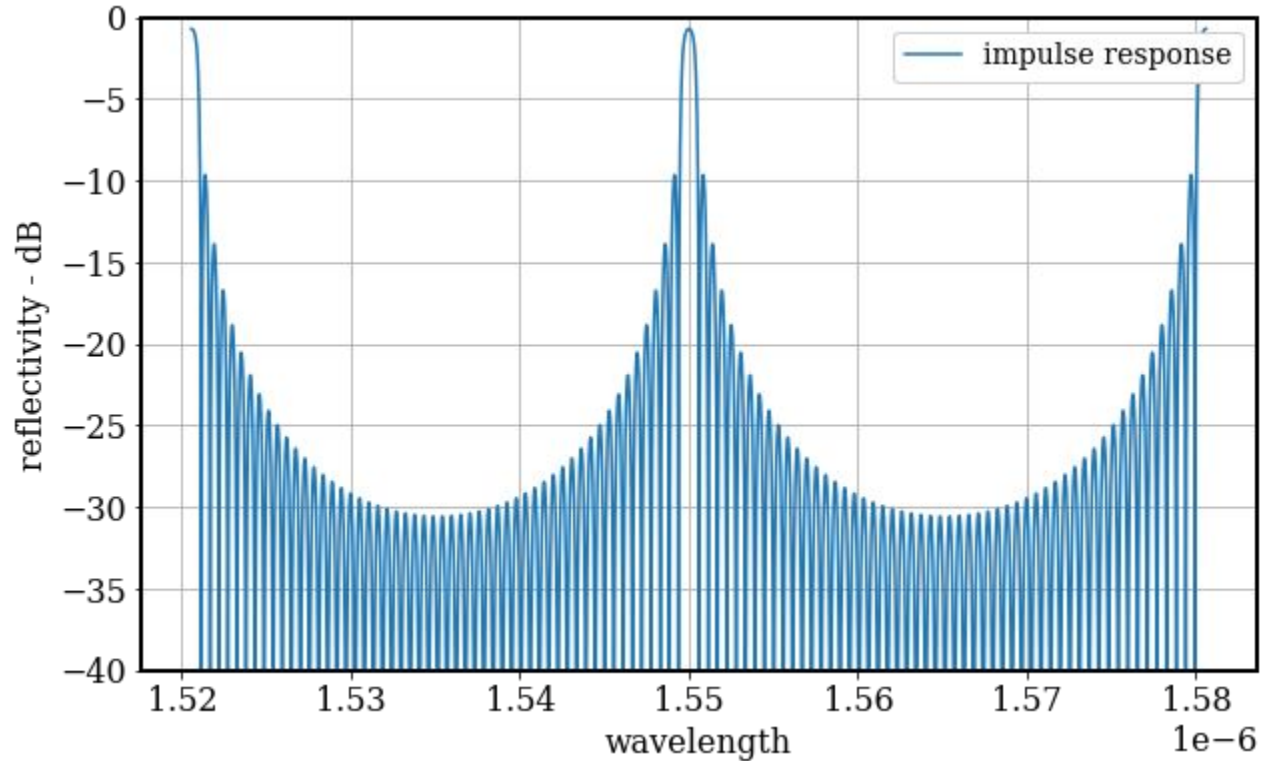


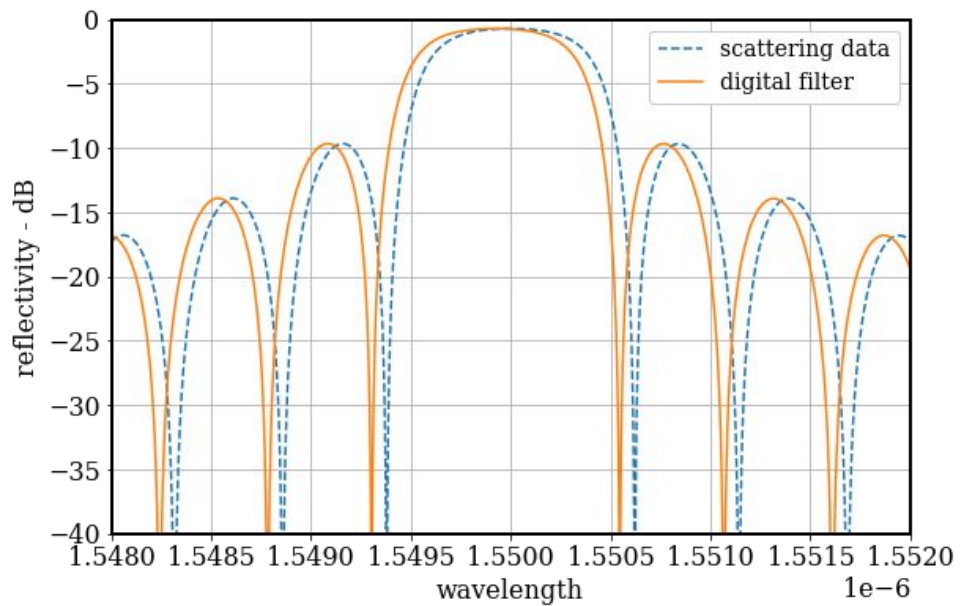
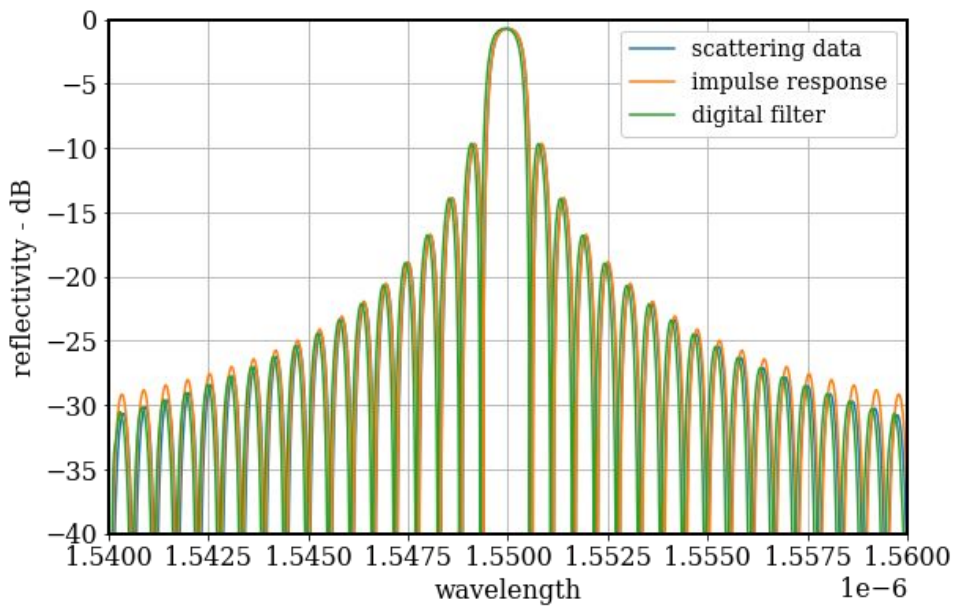


Impulse response = True

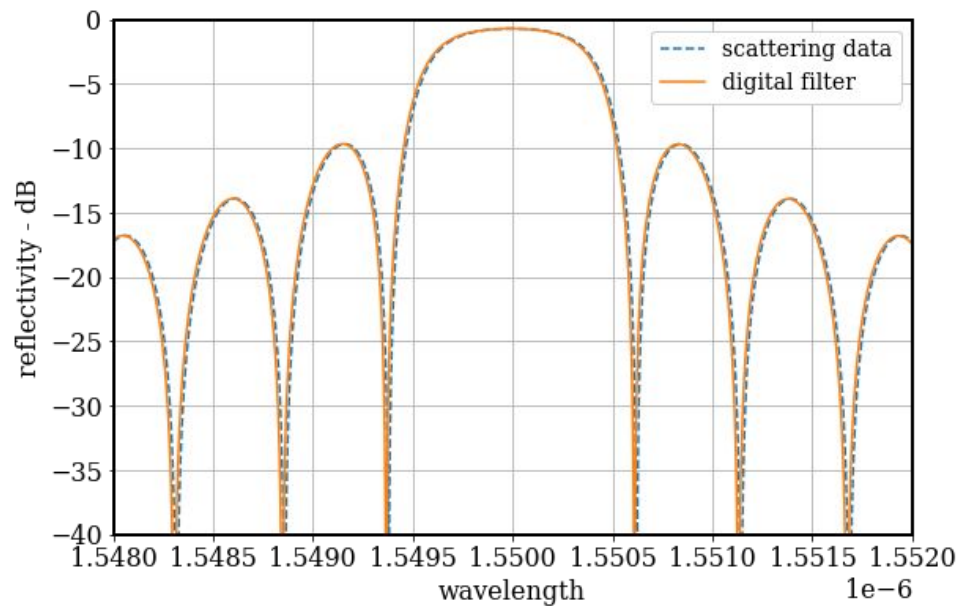
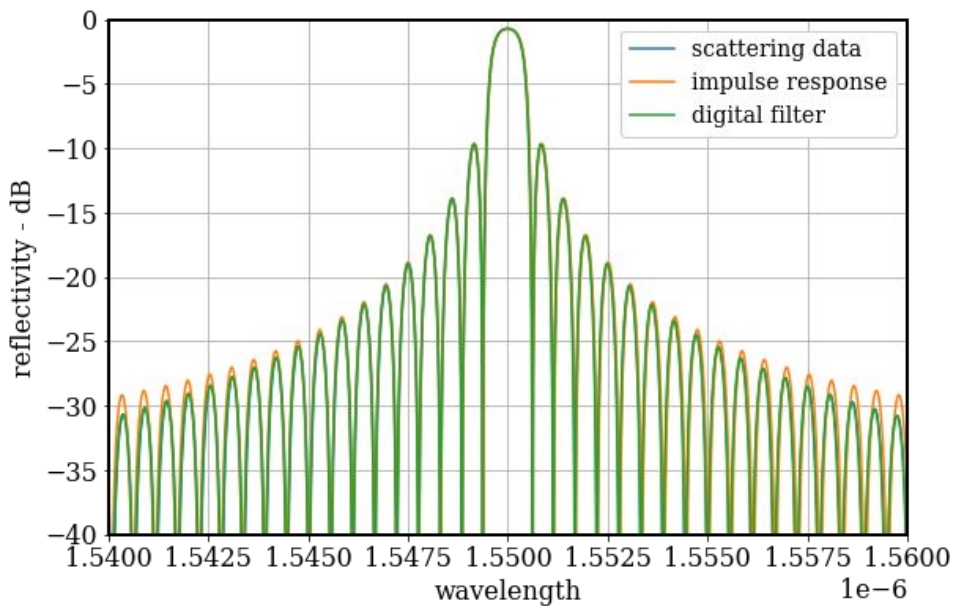
Digital Filter = True

Increasing the bandwidth of the Impulse response to 60nm

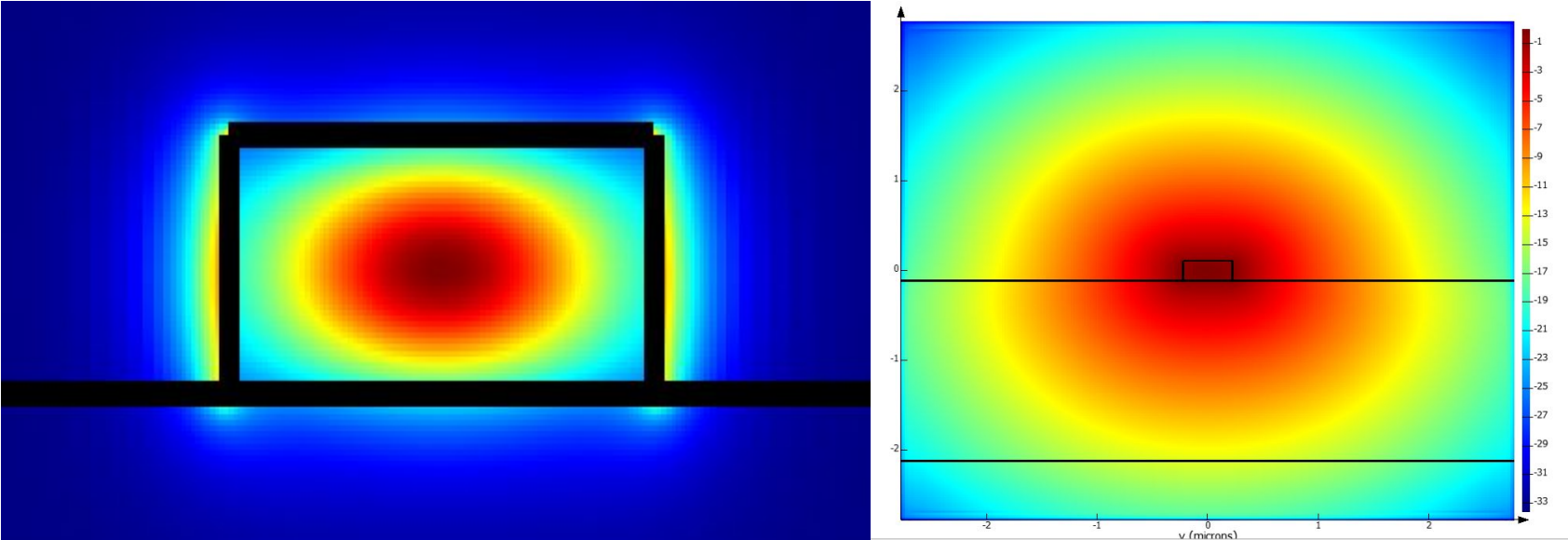




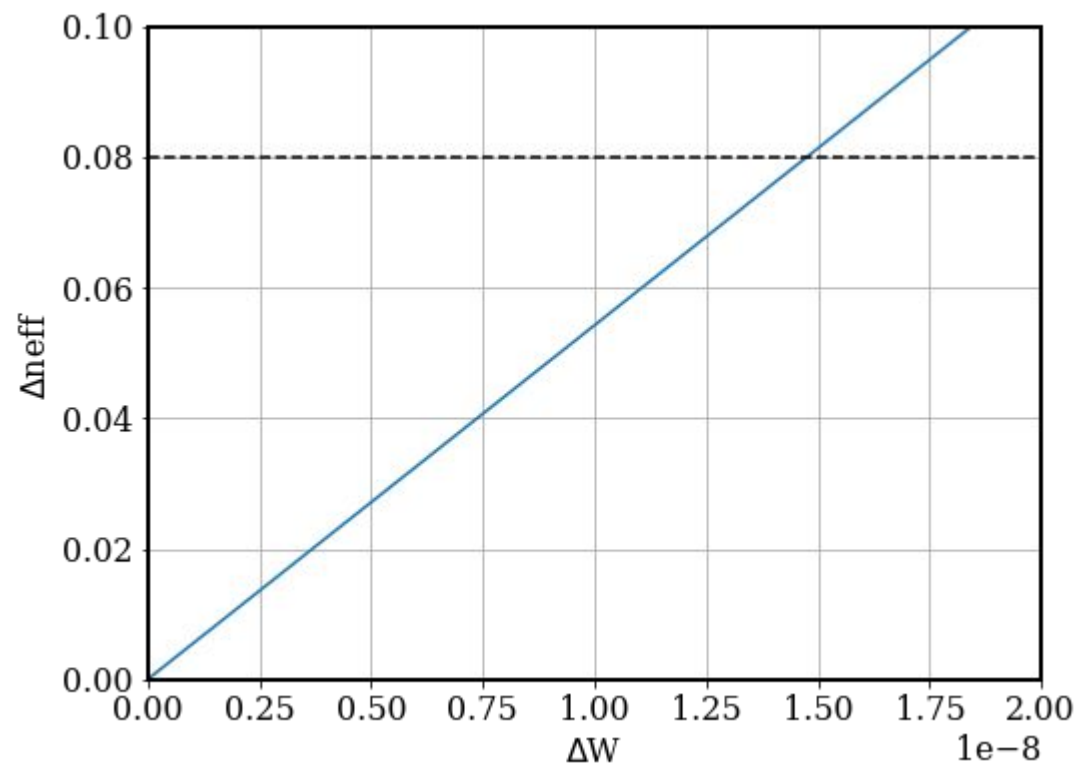
# Increasing the filter order

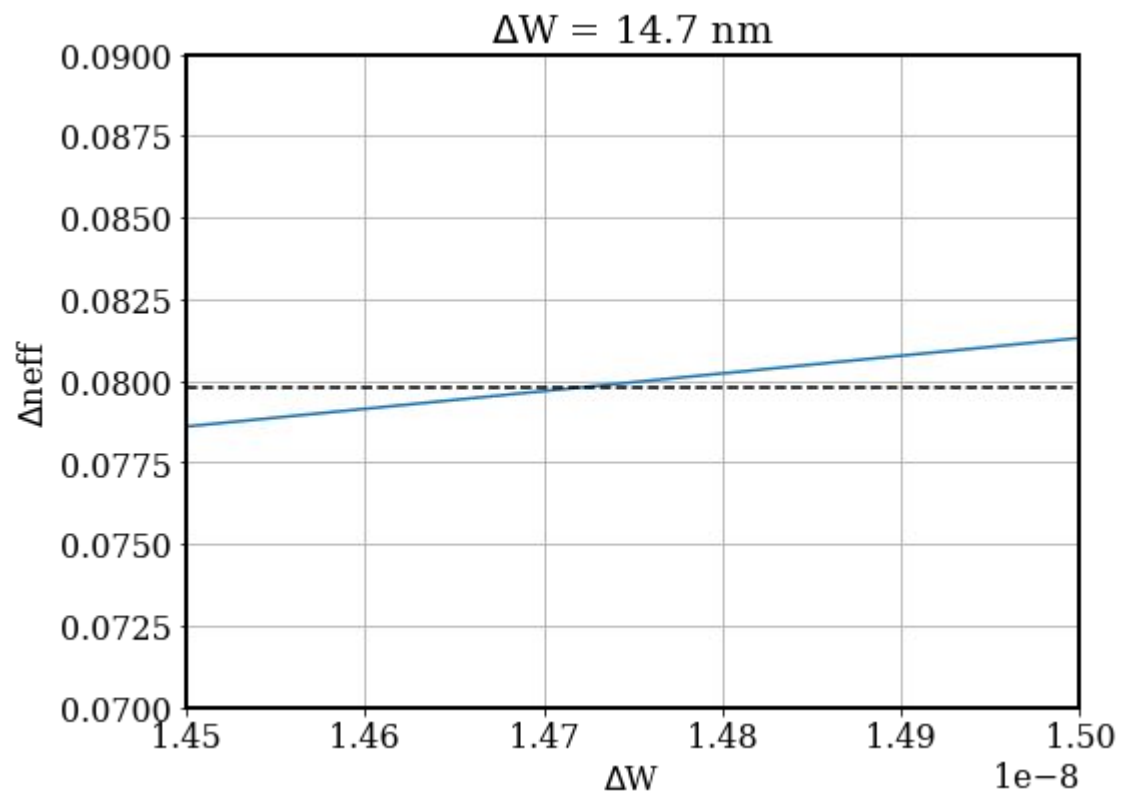


# Device

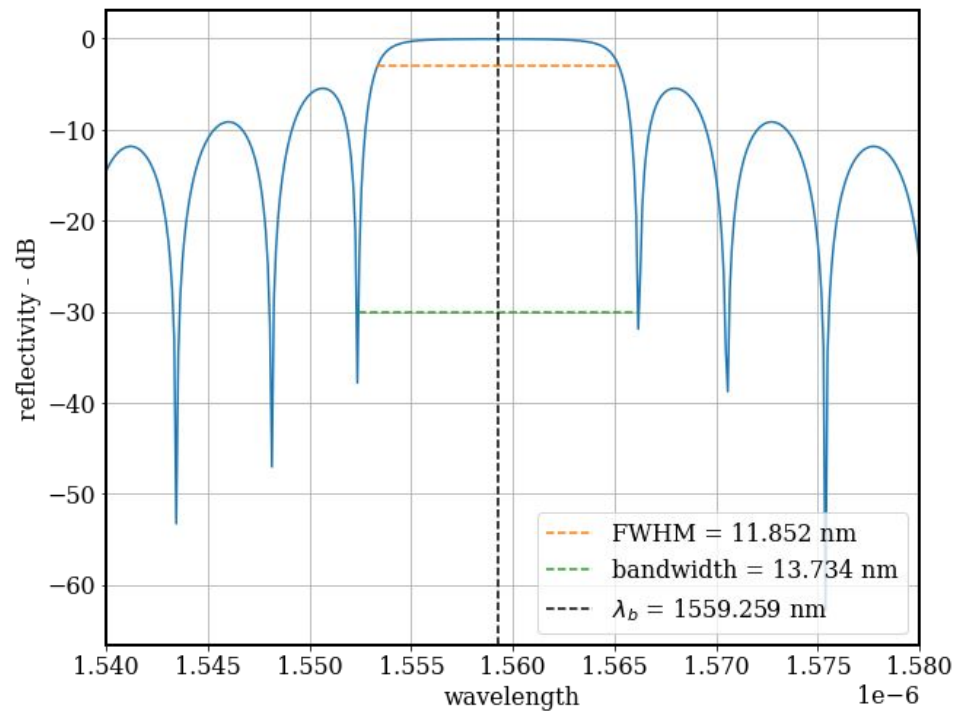
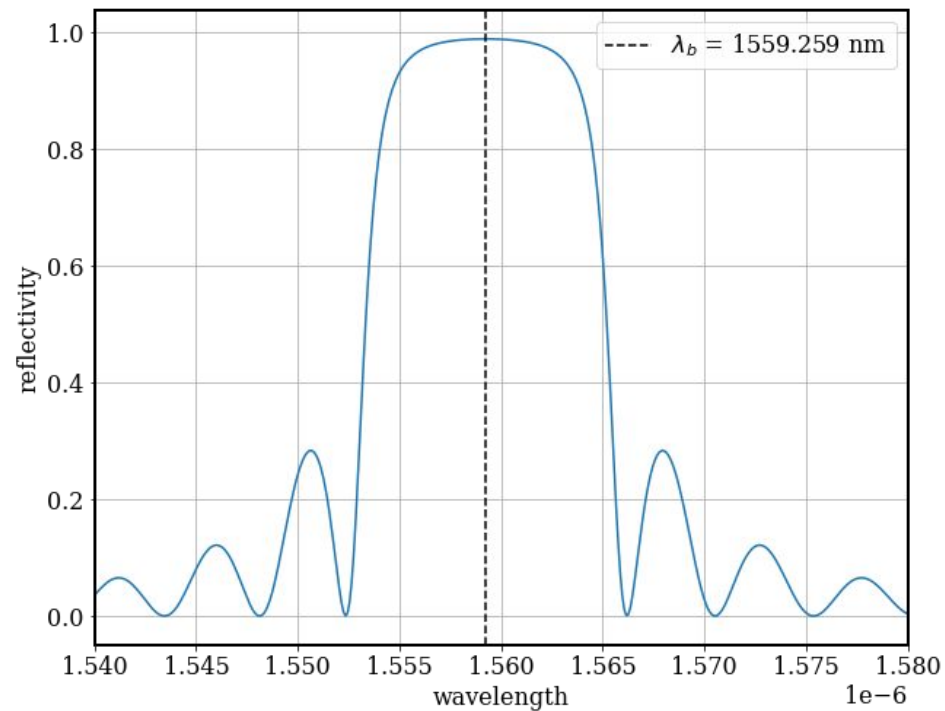


mode #	effective index	wavelength (μm)	loss (dB/cm)	group index	TE polarization fraction (Ey)	waveguide TE/TM fraction (%)	effective area (μm <sup>2</sup> )
1	2.257533+1.600058e-16i	1.56	5.5976e-11	4.606854-2.747917e-17i	97	68.02 / 81.9	0.197562

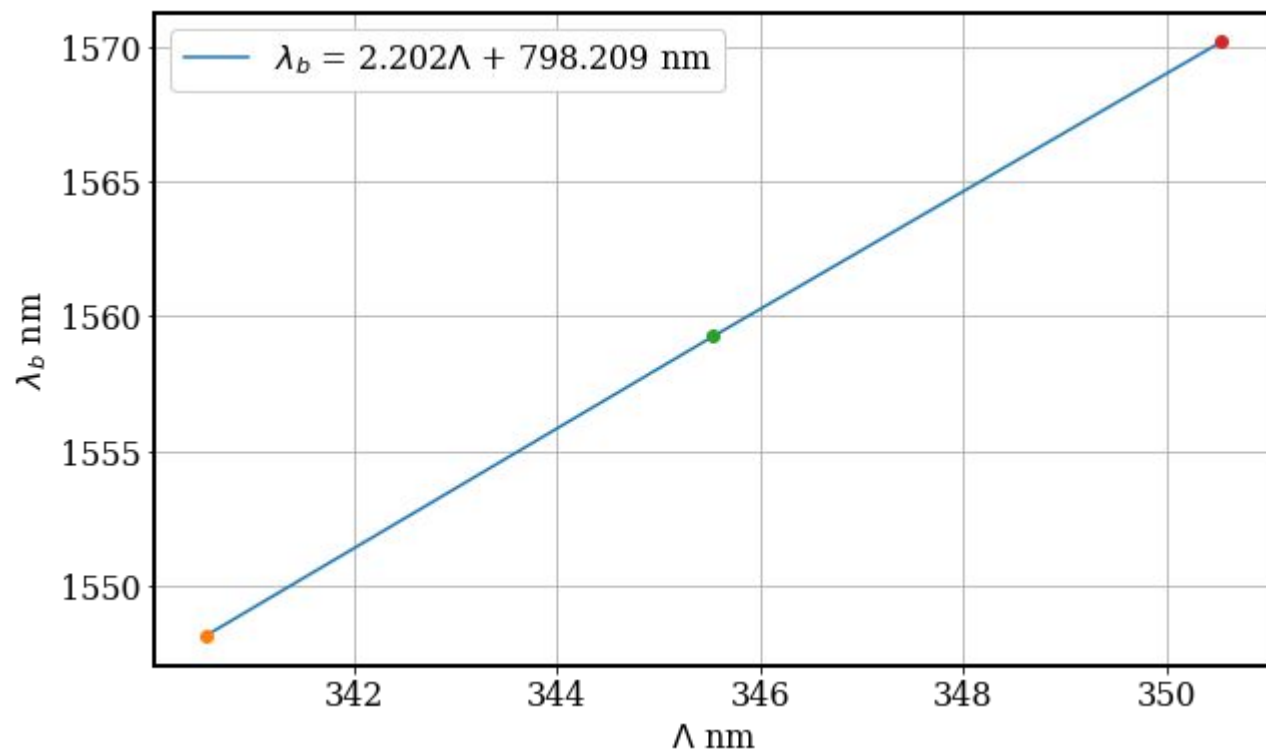




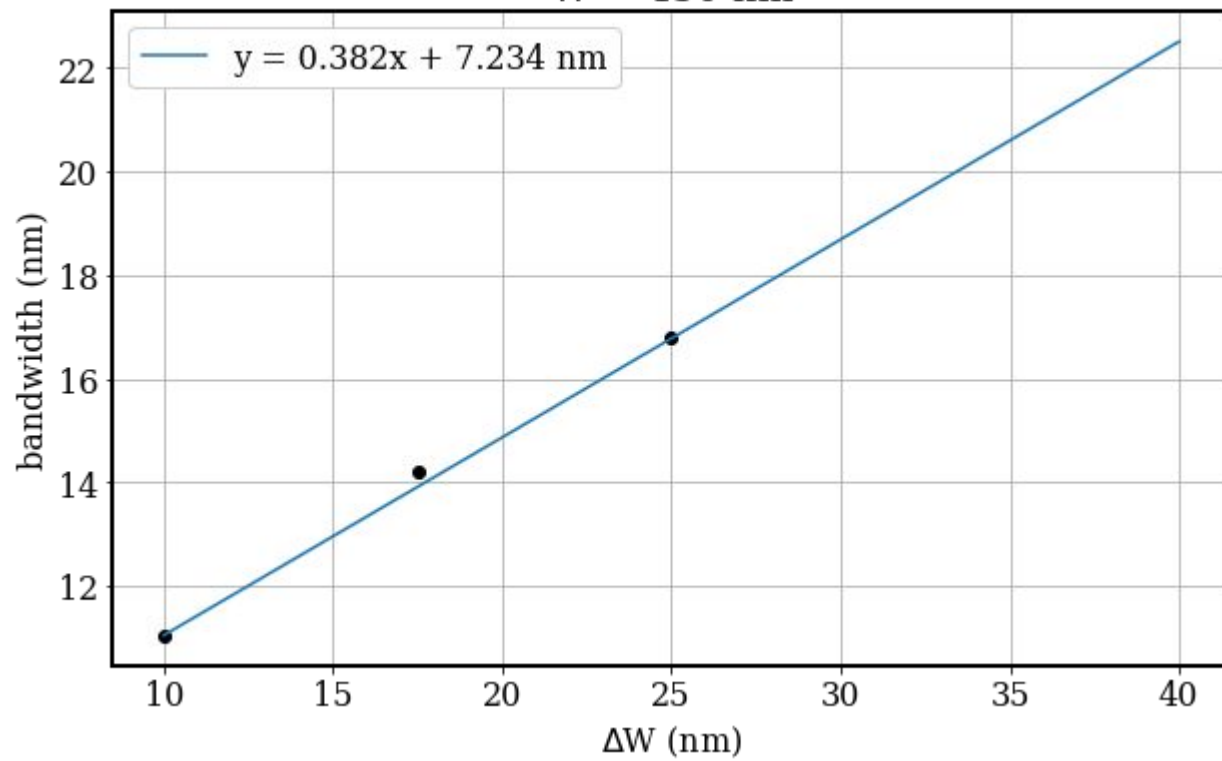
# EME SIMULATION



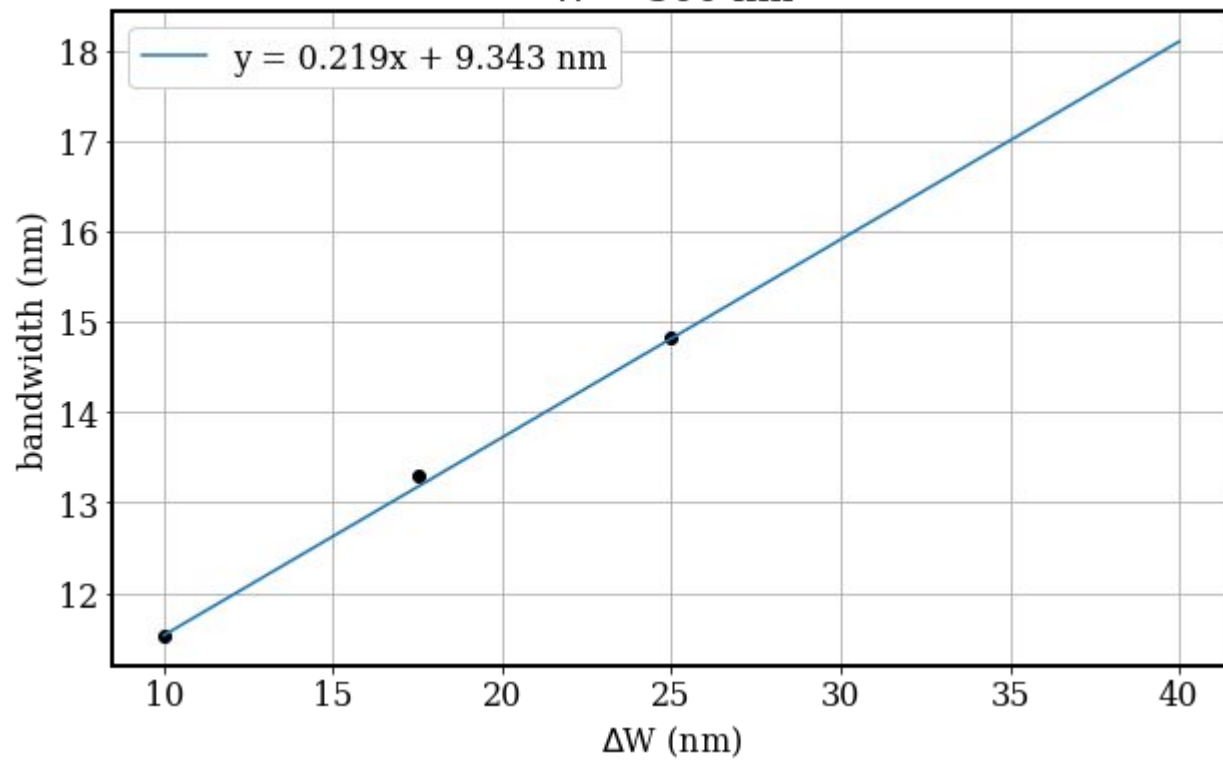


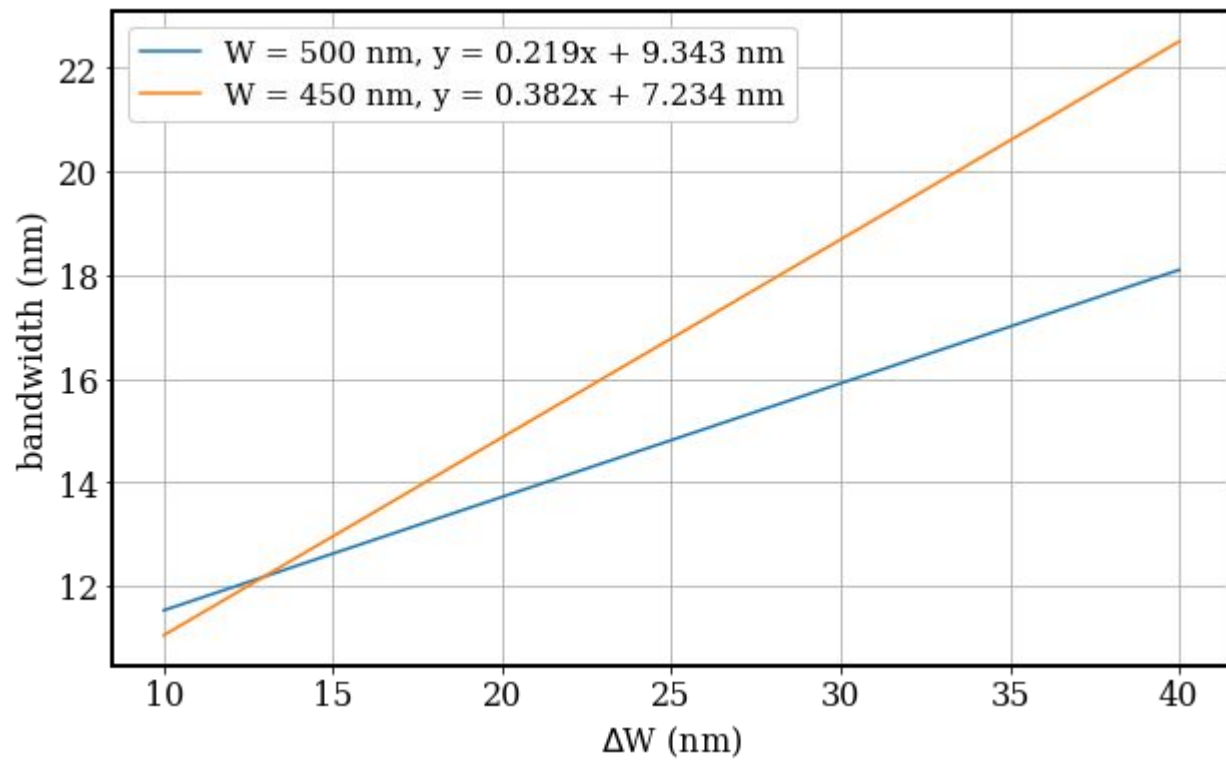


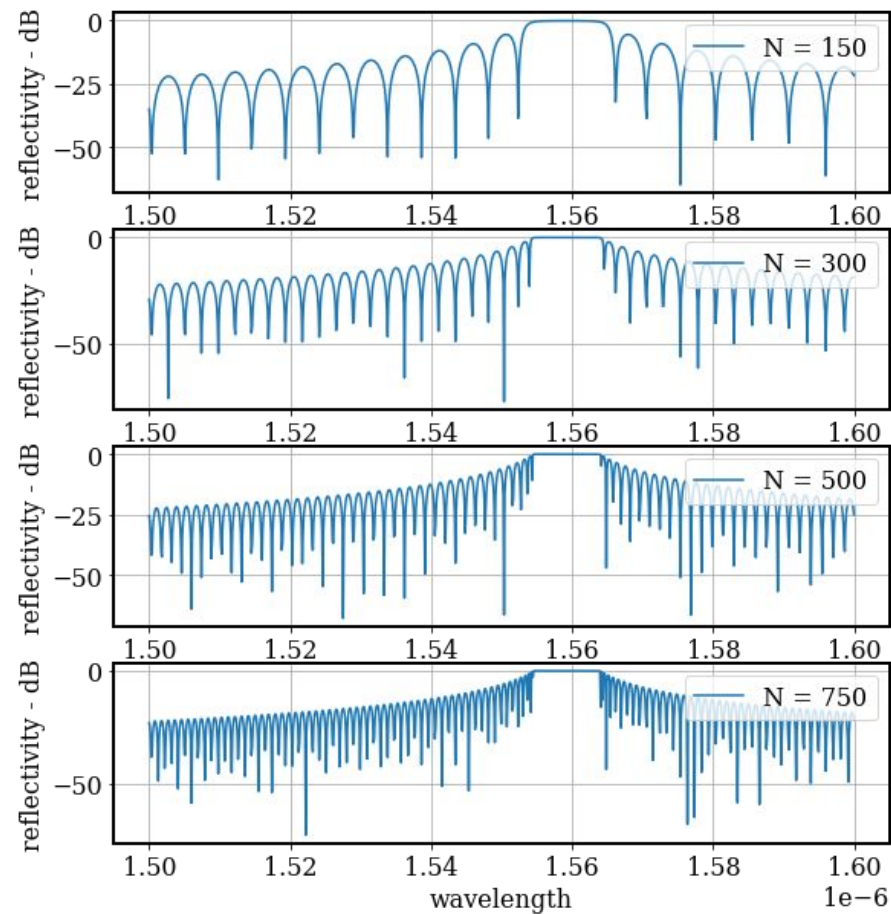
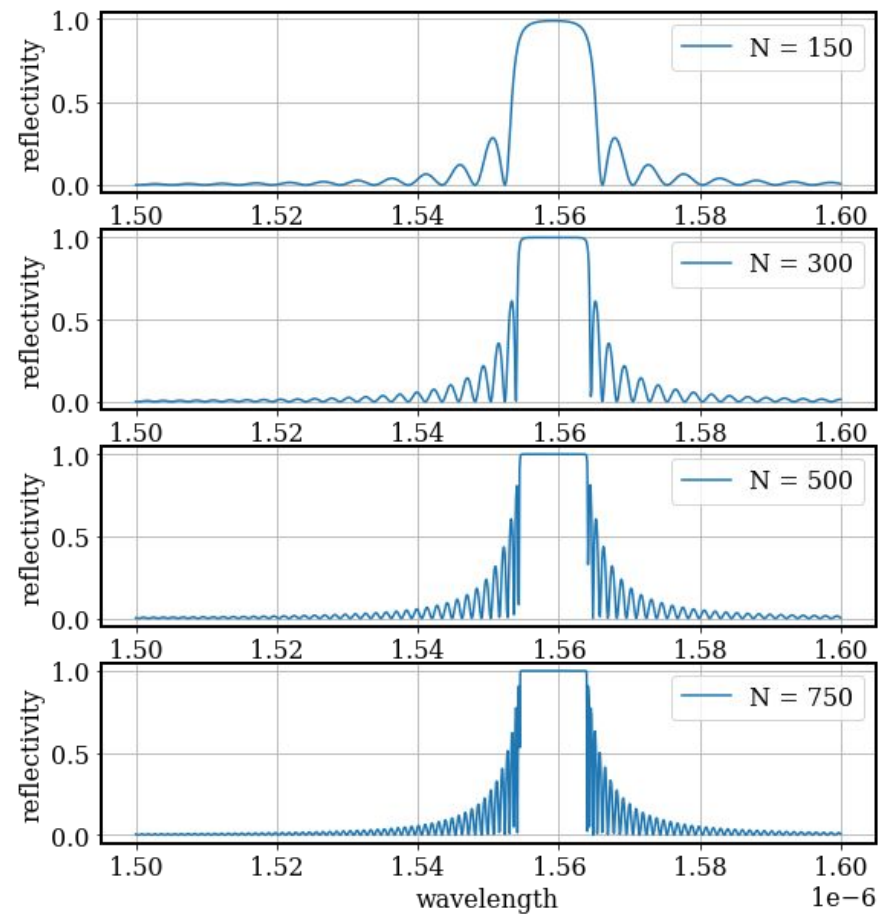
$W = 450 \text{ nm}$



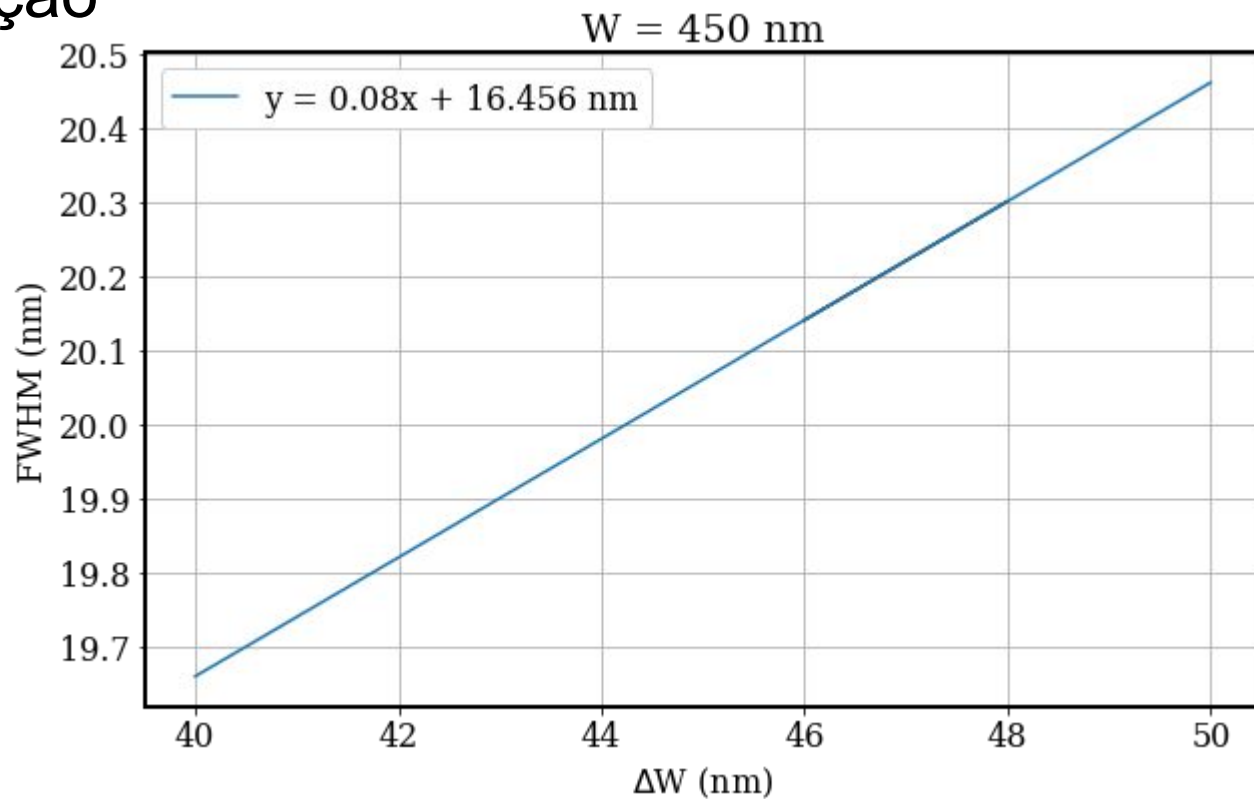
W = 500 nm

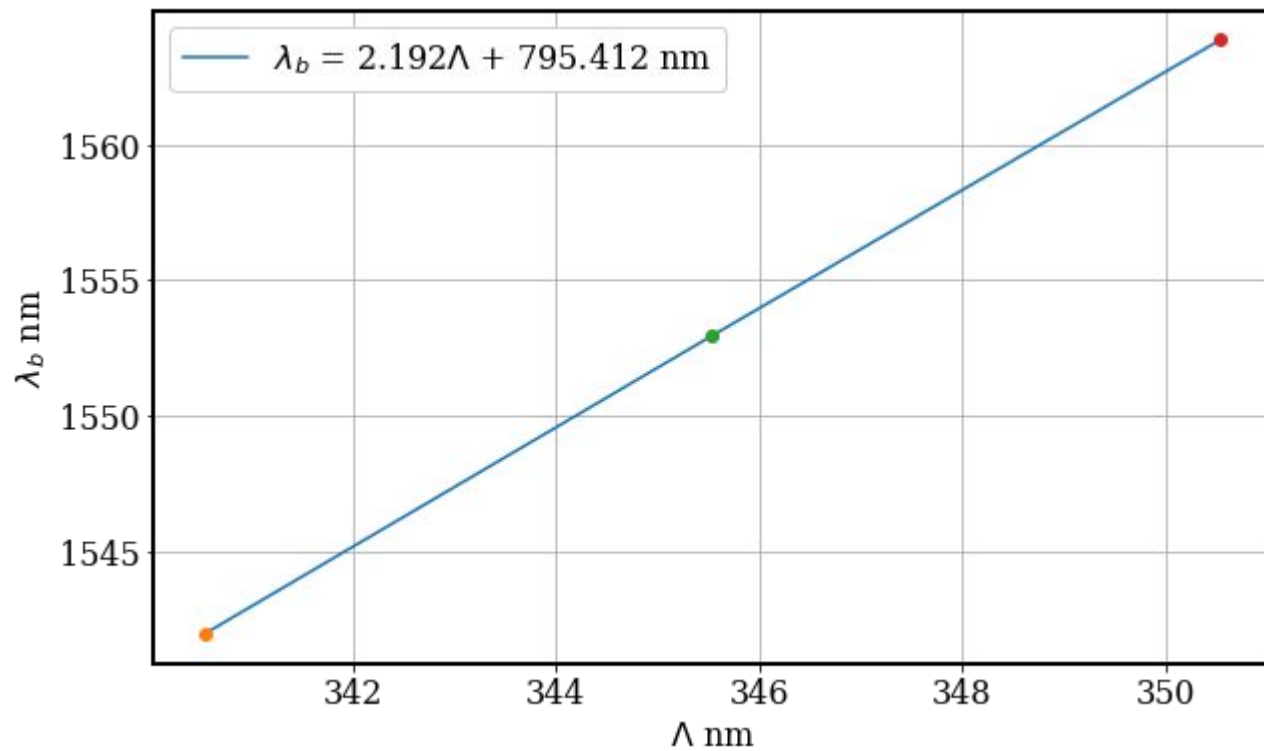


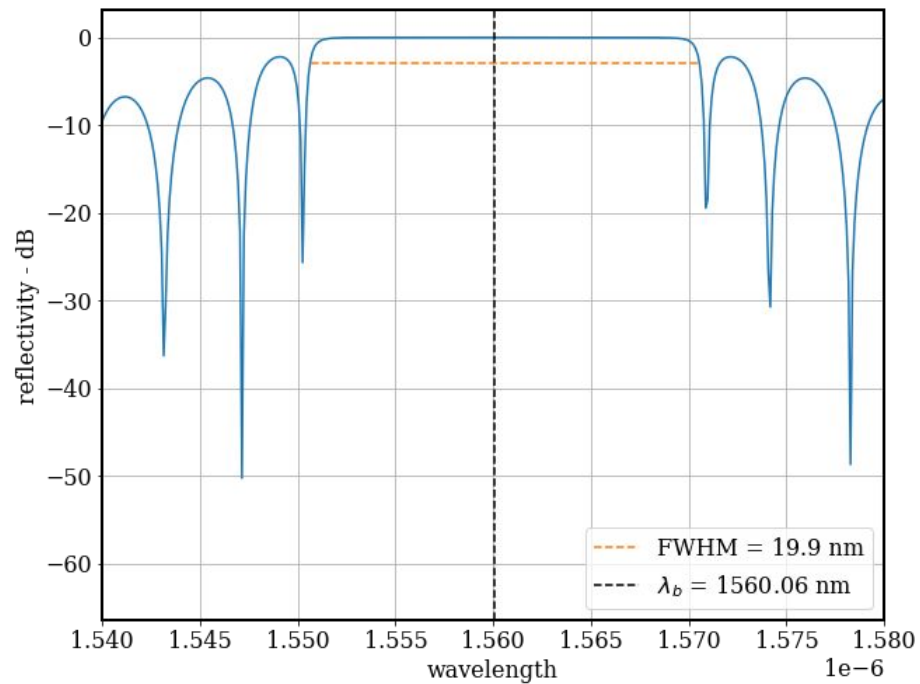
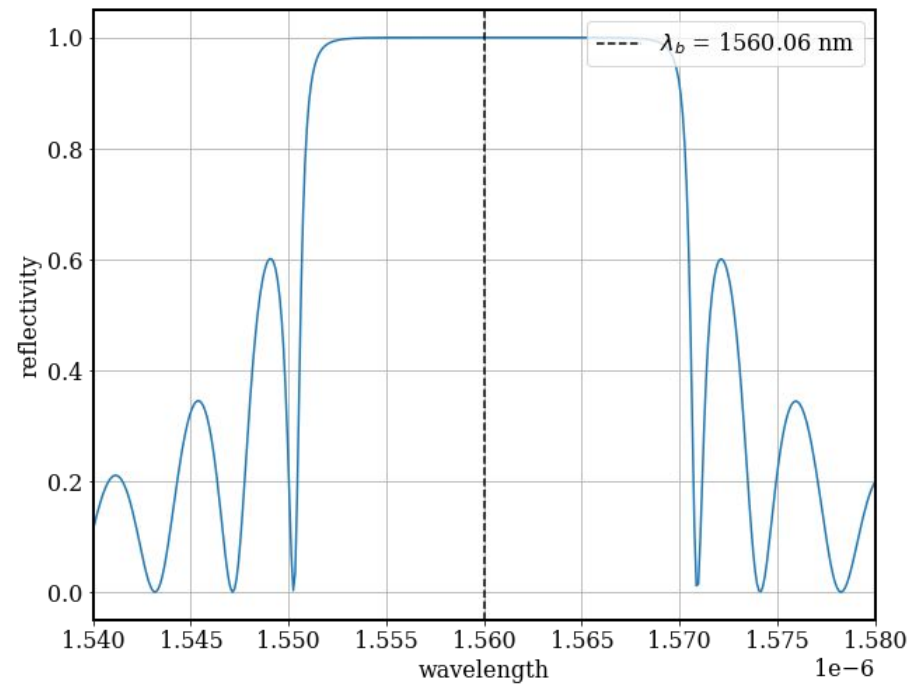




# Otimização





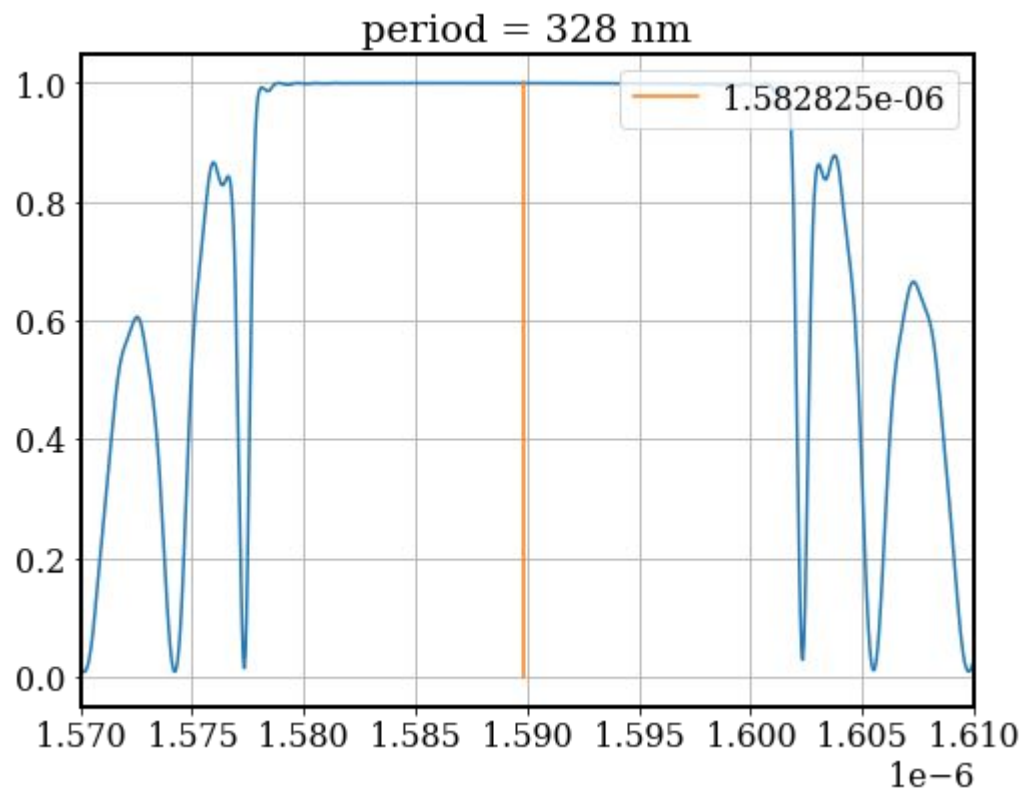


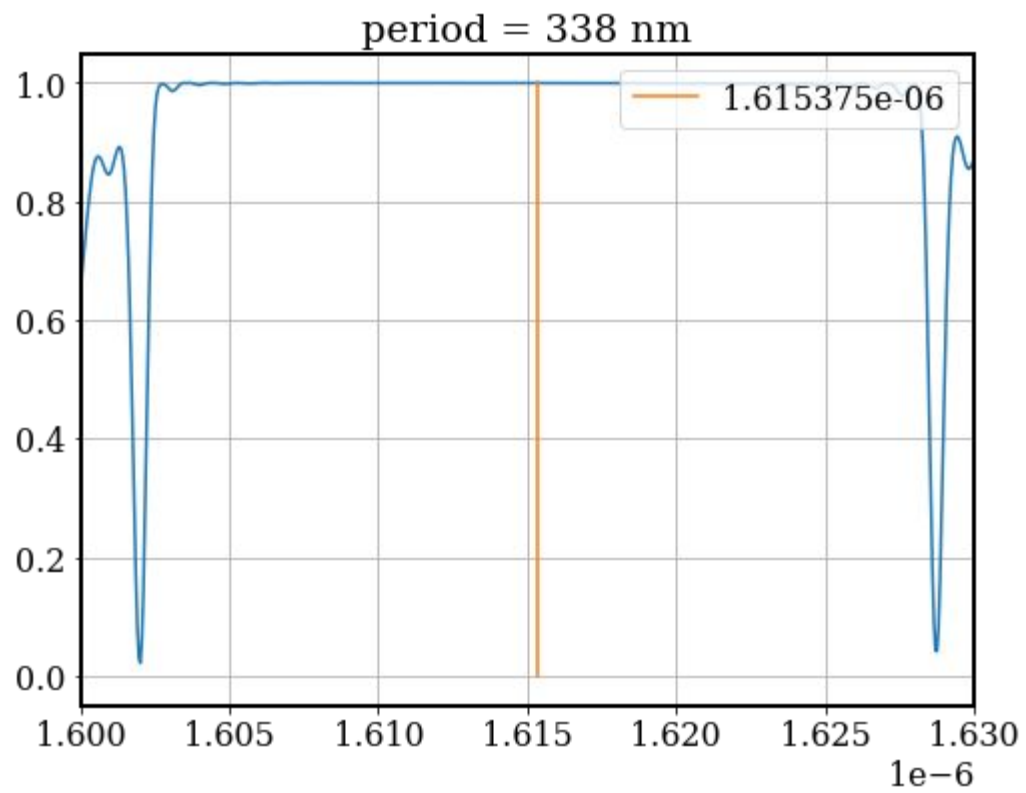
Period = 348.8 nm

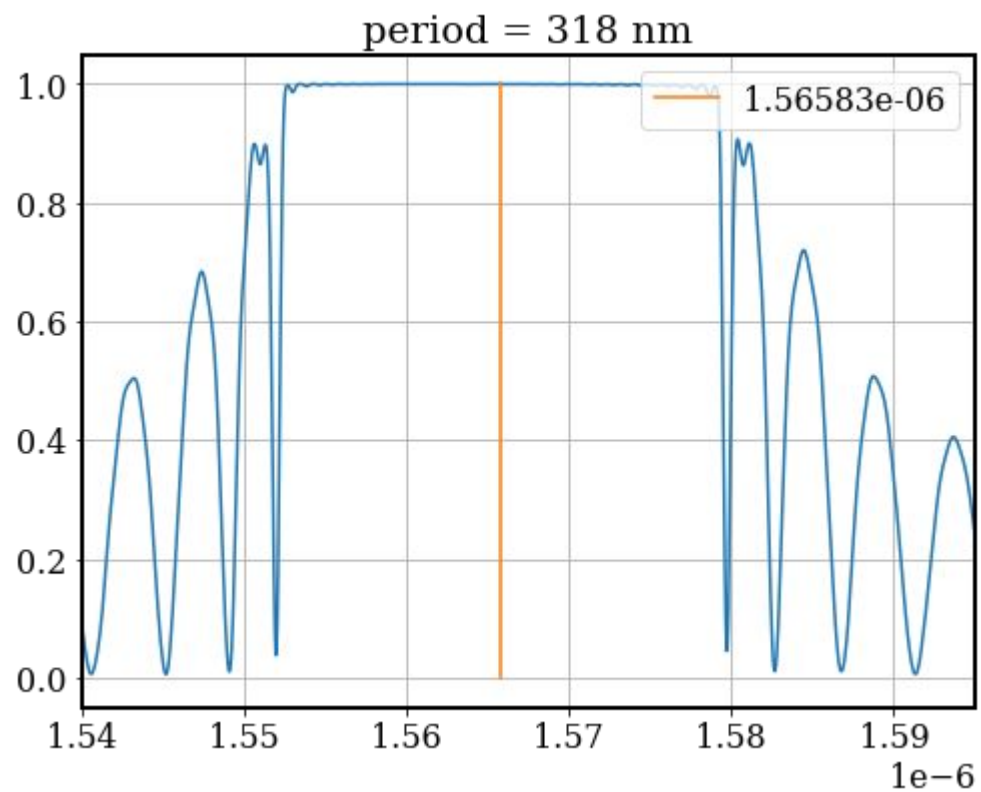
$\Delta W = 44.3 \text{ nm}$

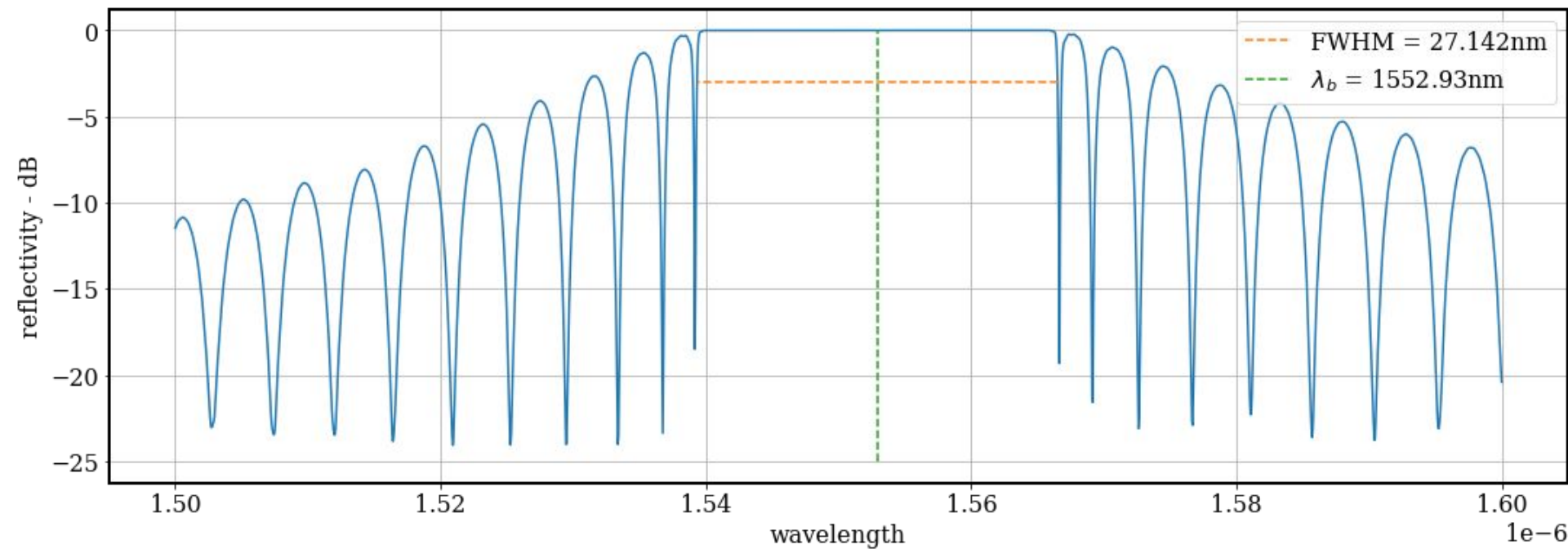


# FDTD SIMULATION



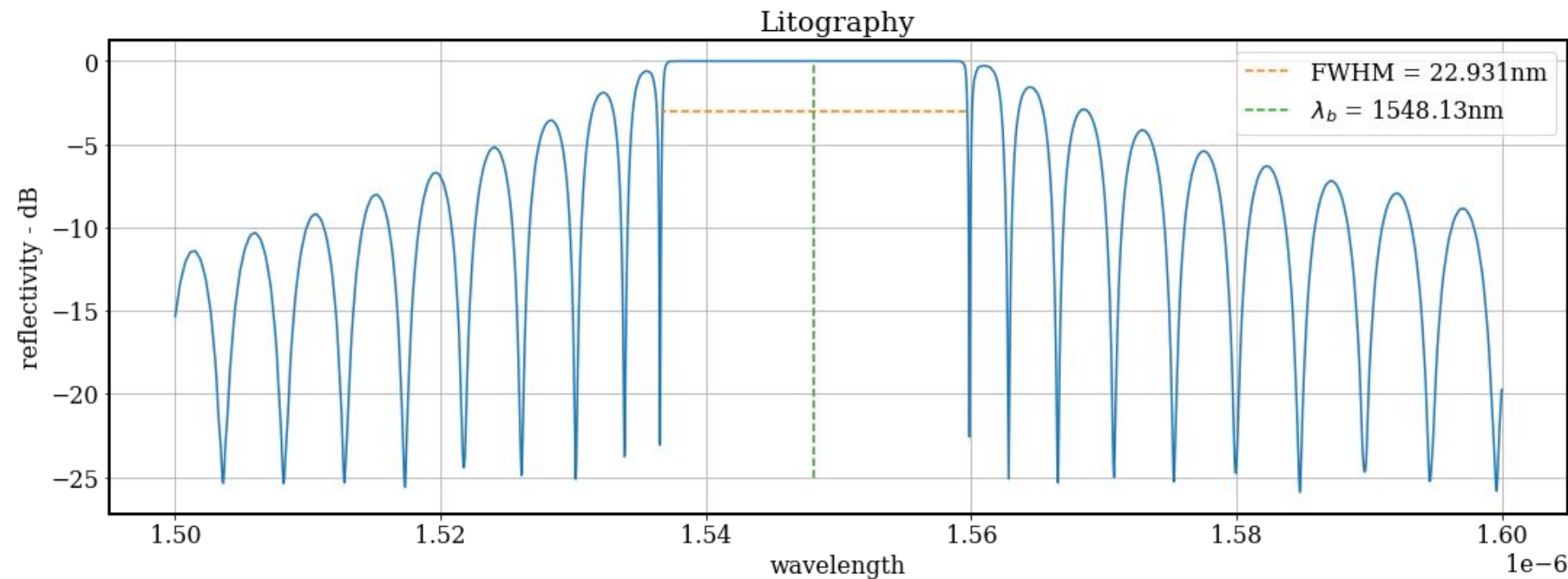




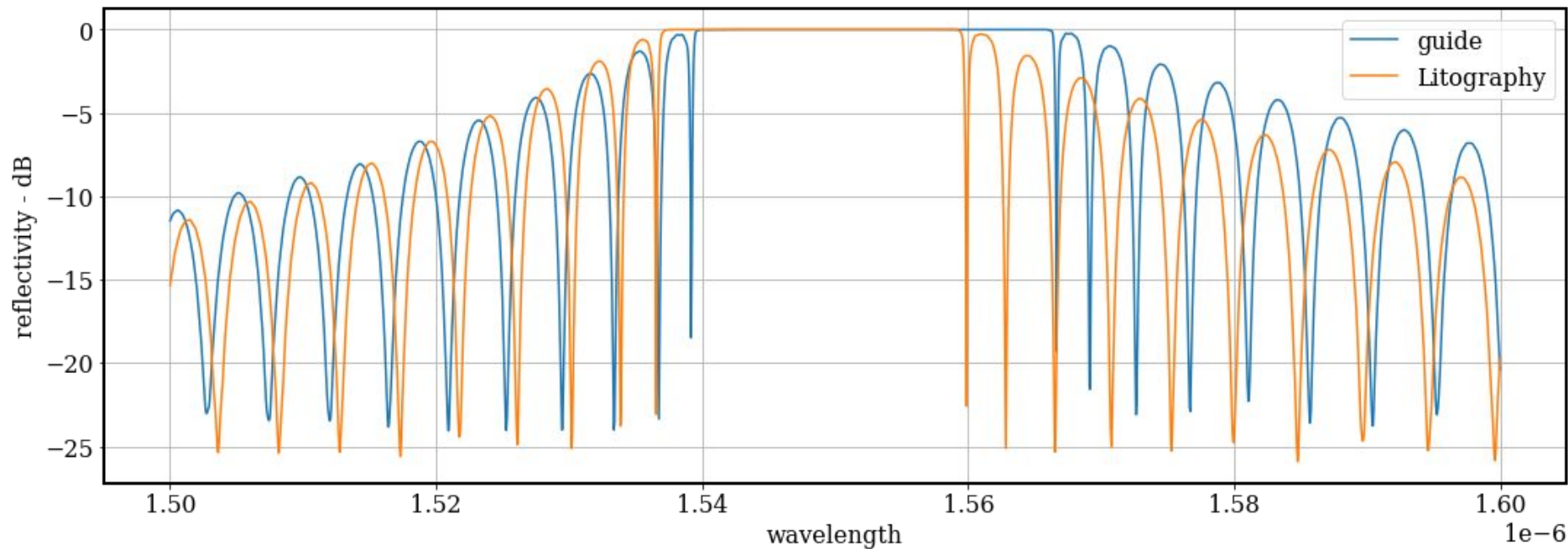


PERIOD = 348.8 nm

# LITHOGRAPHY



Period = 348.8 nm



Period = 348.8 nm  
FDTD SIMULATION